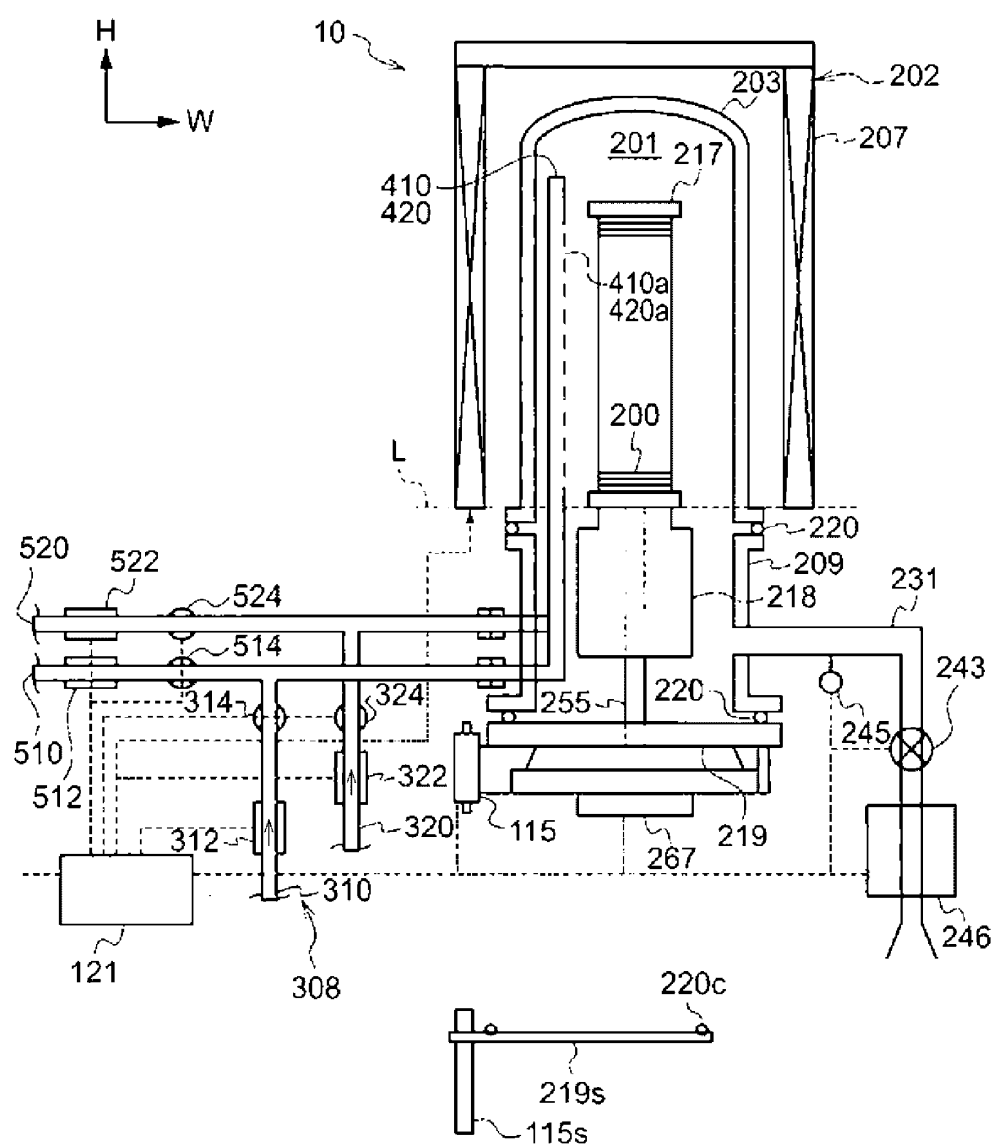
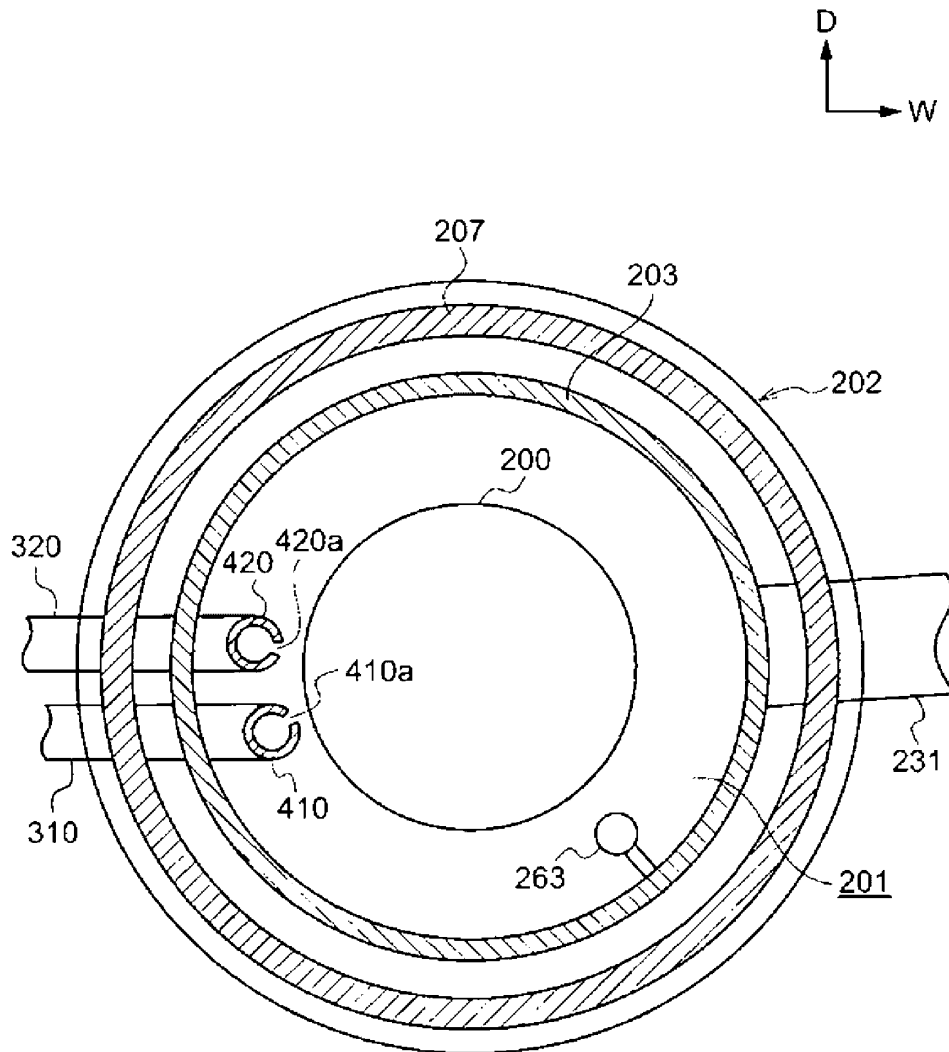


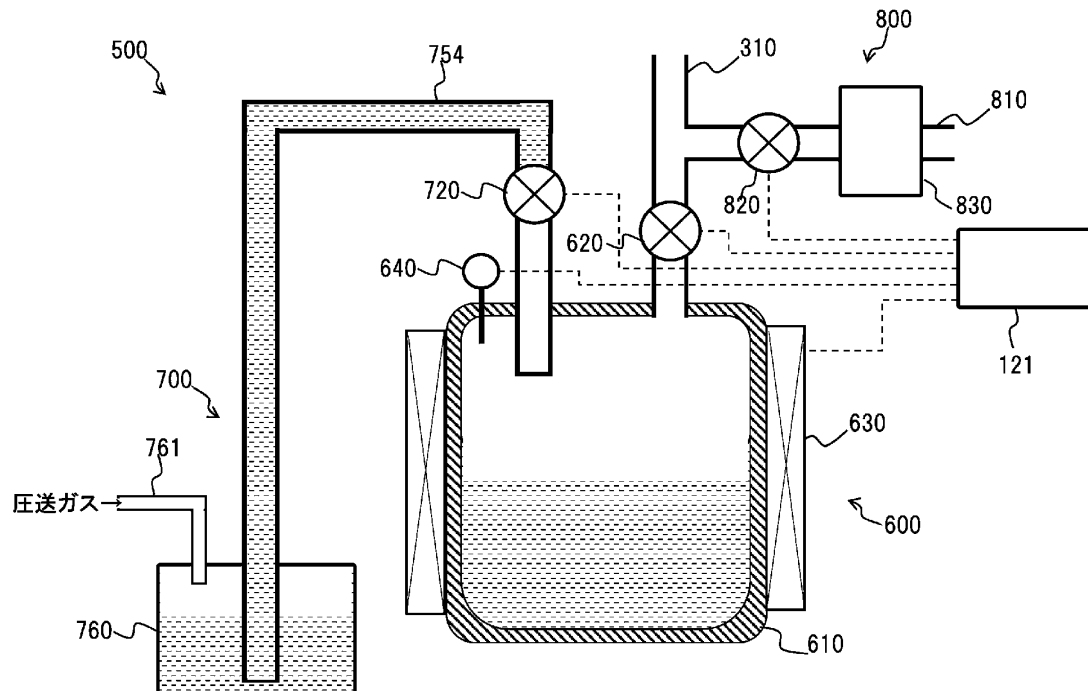
[圖1]



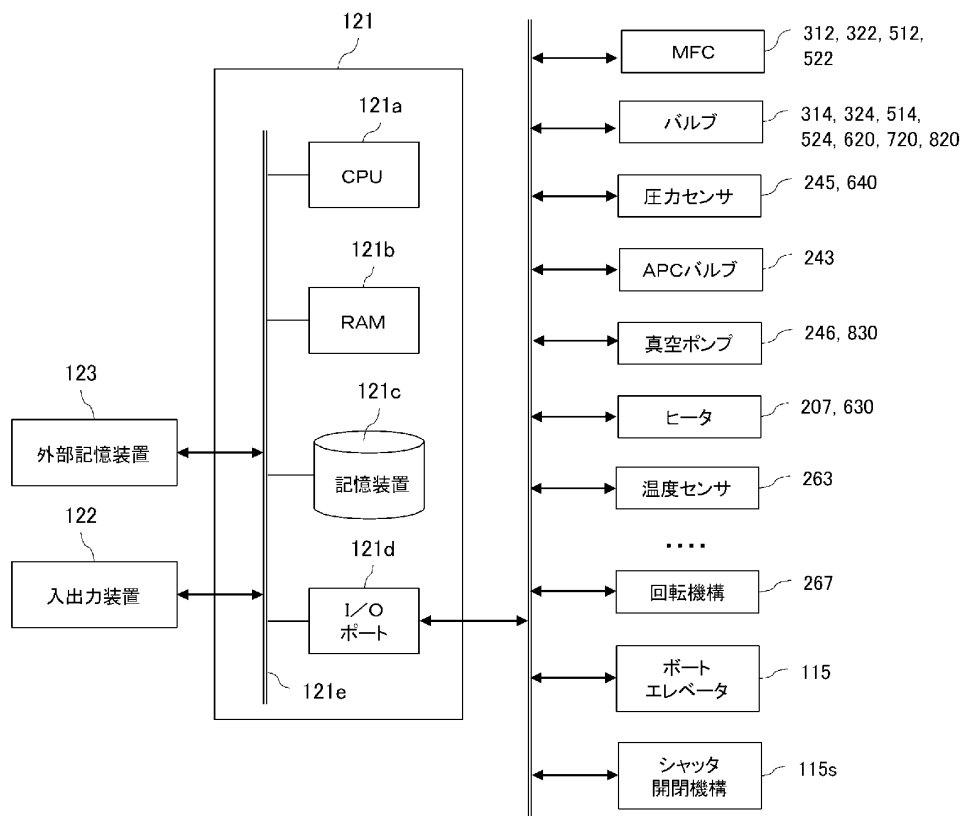
[図2]



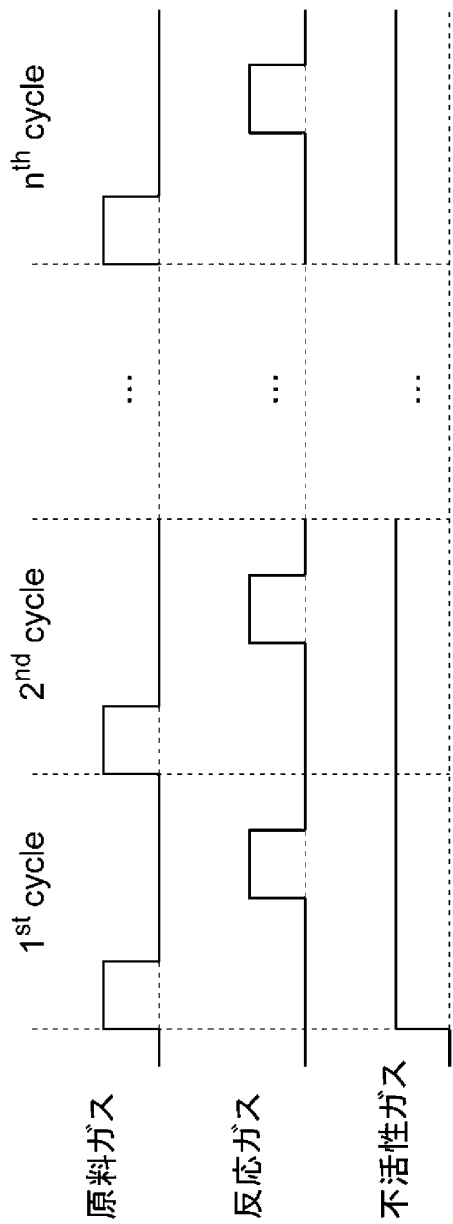
【図3】



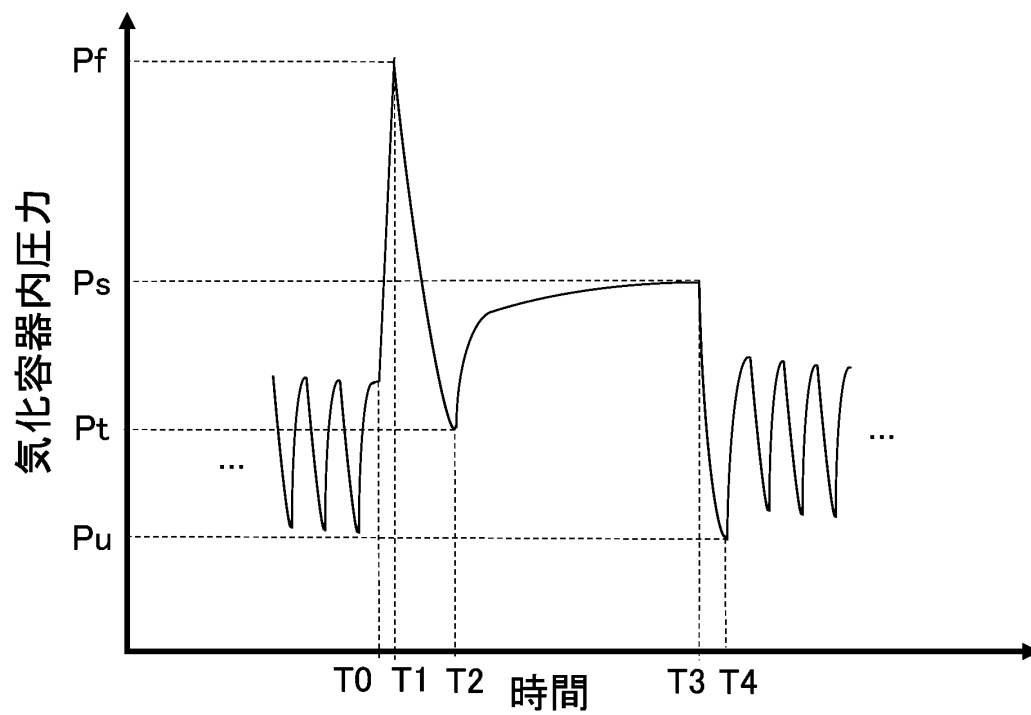
【図4】



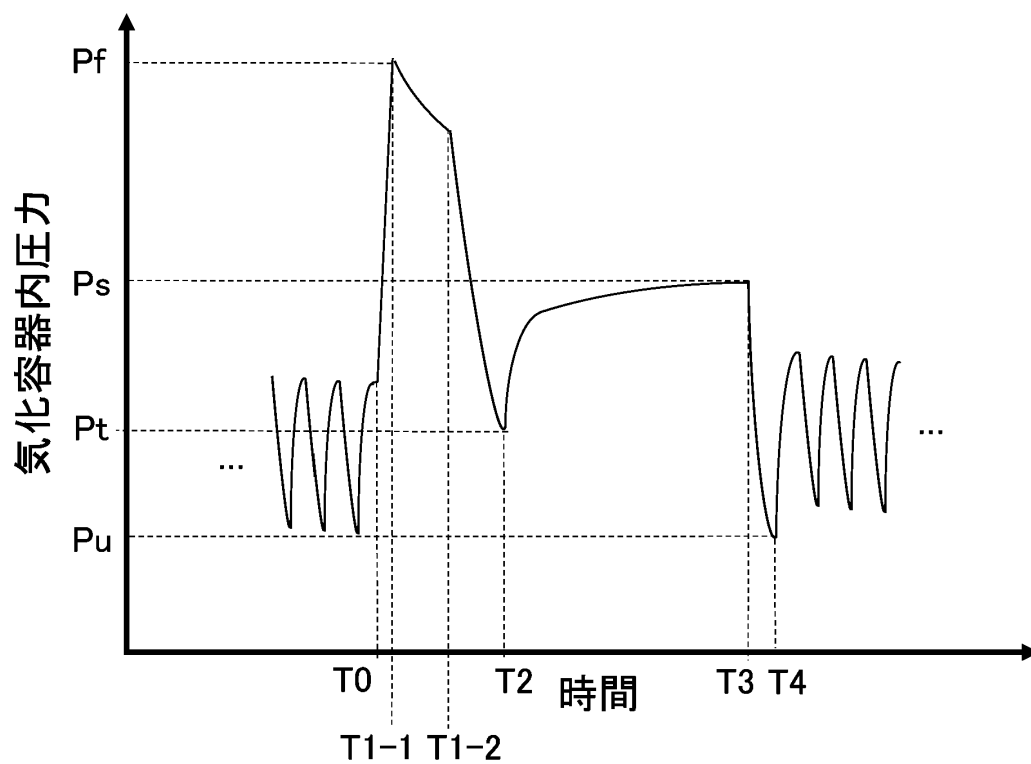
[図5]



[図6]



[図7]



The schematic diagram illustrates a gas supply system. A gas cylinder (760) provides pressurized gas (圧送ガス) to a gas inlet (761). This gas enters a vertical tube (754) that passes through a liquid reservoir (700). The tube (754) is equipped with a valve (720) and a pressure sensor (640). The gas then flows through a horizontal tube (310) which also contains a valve (620). This tube leads to a chamber (600) with a side inlet (630) and a bottom outlet (610). The chamber (600) is connected to a vacuum system (800) via a tube (820) that includes a valve (810) and a pump (830). A control unit (121) is shown with dashed lines indicating its connection to the valves (720, 620, 810) and the pressure sensor (640).